# Supplementary Materials for

# High-order fractal quantum oscillations in graphene/BN superlattices in the extreme doping limit

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This PDF file includes:

Methods

Supplementary Figures

## Methods

## **Device fabrication**

High-quality h-BN crystals were supplied by Taniguchi and Watanabe. The h-BN/graphene/h-BN superlattices on 285nm SiO<sub>2</sub>/Si substrates were fabricated using standard mechanical exfoliation and dry-transfer techniques [S1]. The thickness of h-BN flakes ranges from 8 to 40 nm. The top h-BN is mandatory as it protects the critical graphene layer from environmental surface contamination. During the dry-transfer process, we intentionally aligned the graphene's crystallographic axes with the bottom h-BN layer but misaligned it with the top h-BN layer. Standard electron-beam lithography processes were used to pattern the superlattices into Hall-bar devices with edge contacts (Fig. S1).

#### **Electron-beam doping process**

We use the recently developed electron-beam doping technique to achieve both high nand p-type doping in graphene/h-BN heterostructures [S2]. All heterostructure devices were mounted in a SEM (model: FEI XL30 Sirion) using a custom holder attached to an electrical feedthrough for doping and in-situ electrical measurements. Electron-beam energies of 1keV to 30keV with beam current ( $I_e \sim 10$  pA) and the normal scanning mode were used for electronbeam exposure. The typical exposure time t was ~ 60 s. The accumulated irradiation dosage D is given by  $D = I_e t/Se$ , where S is the exposure area. For  $S = 300 \ \mu\text{m}^2$ ,  $D = 200 \ \mu\text{Ccm}^{-2} = 12.5 \ e^{-n}\text{m}^{-2}$ . We used a standard a.c. voltage bias lock-in technique to perform in-situ transport measurements of the devices in the SEM chamber under a vacuum of 3 x 10<sup>-6</sup> mbar at room temperature.

#### Magneto-transport measurements

Low-temperature measurements were performed in a Quantum Design PPMS system after quickly transferring the doped sample from the SEM without significant exposure to ambient light. Such precautions were followed for all measurements reported in this work as light exposure to the doped sample might cause an additional photoinduced doping. Fourterminal resistances were measured using lock-in amplifiers (SRS 830) while the gate voltage was sourced through a Keithley source-meter (Keithley 2400).

# **Theoretical simulations**

This wave packet method used here allows us to straightforwardly probe qualitatively different transport behaviors in the ballistic regime by following the mean quadratic displacement of the wave packets [S3–S5]. Note that the ballistic regime is often mostly avoided because the extracted conductivity will depend on the specific timestep of the evolution method making it difficult to make quantitative predictions. However, in this work we focus on this unusual regime allowing us to avoid the effects of disorder yet leveraging the fact that even in the ballistic regime, the conductivity captures the BZ oscillations qualitatively. We are not aware of other studies extracting the BZ oscillations in this way.

As this method gives access to the intensive conductivity observable, as opposed to Landauer formalism implementations which depend on the length of the system, in the ballistic regime we are limited to qualitative values of conductivity rather than a quantitatively welldefined number, by arbitrarily stopping the evolution of the wave packets after a large number of evolution steps. Such an approach proves itself able to clearly resolve BZ oscillations. The simulations occur at zero temperature, and thus can still resolve the Landau level features in the

background. We use a reduced number of 2000 recursion steps to limit computation time needed to evaluate the mean-quadratic displacement at several time-steps on a 20-million atoms system to avoid spurious self-interacting wave-packet effects due to the periodic boundaries. The TB model itself is obtained by mapping out at the Brillouin-zone corner of graphene K = $(4\pi/3a \ G, 0)$  (with a G the graphene lattice vector) [S3] a well-established continuum model given by  $H = H \ 0(\vec{r})\sigma \ 0\tau \ 0 + H \ z(\vec{r})\sigma \ 3\tau \ 3 + \vec{H}_{xy}(\vec{r})\cdot\vec{\sigma}\tau \ 3$  with the pseudospin moire components  $H_0(\vec{r}) = 2C_0Re[f(\vec{r})e^{i\phi_0}]$  and  $H_z(\vec{r}) = 2C_zRe[f(\vec{r})e^{i\phi_z}]$  for the diagonal terms and  $H_{xy}(\vec{r}) = 2C_{xy}[\cos{(\phi)}(\vec{z} \times 1) - \sin{(\phi)}] \times \nabla Re[e^{i\phi_{xy}}f(\vec{r})]/|\vec{G}_1| \quad \text{for}$ the off-diagonal terms [S6]. Diagonal terms are directly modifying the onsite energies of the TB model while for the off-diagonal terms, noting that  $\vec{H}_{AB} = \vec{H}_{AB}^{*}$ , we can obtain the hBN-induced corrections  $\delta_i$  to the graphene TB hopping terms using  $\vec{H}_{AB} = \delta_1 - \frac{\delta_2 + \delta_3}{2} + i \frac{\sqrt{3}}{2} (\delta_3 - \delta_2)$  leading to  $\delta_1 =$  $\frac{2}{3}Re(\vec{H}_{AB})$  and  $\delta_{2,3} = \frac{-Re(\vec{H}_{AB}) \pm \sqrt{3}Im(\vec{H}_{AB})}{3}$ [3]. We use the rigid G/BN system parameters  $C_0 =$ 10.13 meV,  $C_z = 9.01$  meV,  $C_{xy} = 11.34$  meV,  $\phi_0 = 146.53^\circ$ ,  $\phi_z = 68.43^\circ$  and  $\phi_{xy} = 68.43^\circ$ -109.6° [6].

# **Supplementary Figures**



FIG. S1. Optical images of h-BN/graphene/h-BN superlattice devices. The superlattices (Device A and Device B) are shaped into Hall-bar geometry using standard electron beam lithography and reactive ion etching processes.



FIG. S2. High-order fractal BZ oscillations in highly electron-doped and hole-doped graphene/h-BN superlattice (Device A). (a) Longitudinal conductivity  $\sigma_{xx}$  as a function of  $\phi_0/\phi$  measured at various electron density *n* from  $1.3n_0$  to  $3.7n_0$  with a step of ~  $0.14n_0$ . Here, the characteristic carrier density for the superlattice  $n_0 = 2.3 \times 10^{12} \text{ cm}^{-2}$ . (b)  $\sigma_{xx}$  as a function of  $\phi_0/\phi$  for electron density  $n = 1.9n_0$  at various temperatures from 200 K to 50 K. (c)  $\sigma_{xx}$  as a function of  $\phi_0/\phi$ measured at various hole density *n* from  $-1.2n_0$  to  $-4.0n_0$  with a step of ~ $0.14n_0$ . (d)  $\sigma_{xx}$  as a function of  $\phi_0/\phi$  for hole density  $n = -4.0 n_0$  at various temperatures from 200 K to 50 K. The vertical dashed lines and arrows indicate the magnetic field positions where the fractal BZ states with p = 2, 3 and 4.



FIG. S3. Simulated magnetoconductivity as a function of carrier density at magnetic fields corresponding to selected fractal BZ states for hole-doped graphene/h-BN superlattices. Left panels in (a) and (b) are raw conductivity data extracted from Fig. 4(a) with (a) p = 2 and (b) p = 3. Right panels in (a) and (b) are obtained by taking a moving average of the data in left panels covering about 30 percent of the charge carrier density shown here. This allows dampening the Landau level oscillations while resolving the maximum in conductivity. The

conductivity amplitude first increases with carrier density and then gradually decreases or saturates at around  $-3n_0$ , agreeing with experimental observations in Fig. 3(e).

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